

Search Notes

Application/Control No.

10/824,215

Examiner

José V. Chen

Applicant(s)/Patent under
Reexamination

LENG, LU HAO

Art Unit

3637

SEARCHED

Class	Subclass	Date	Examiner
108/	27		
	161		
	59		
	153.1		
	157.14		
updated		1/10/2008	JVC

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
108	27		
	59		
	153.1,161	1/10/2008	JVC

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
updated search		
int text search history	1/10/2008	jvc